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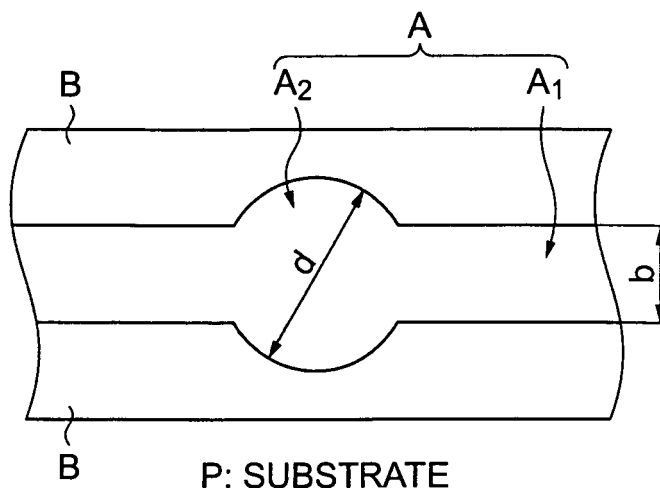
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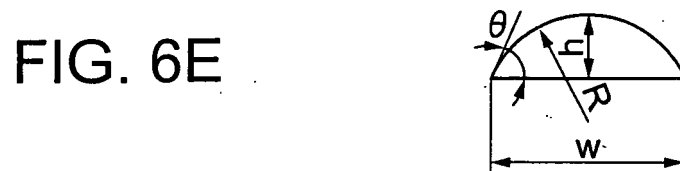
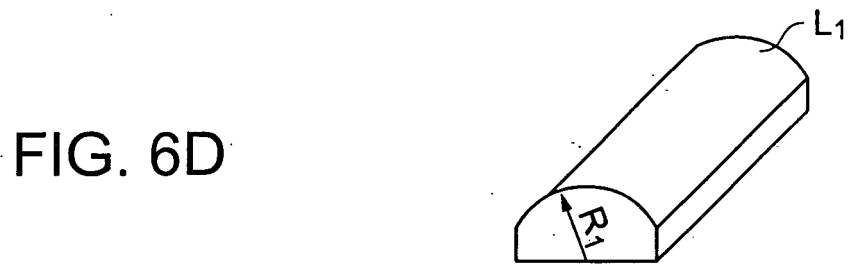
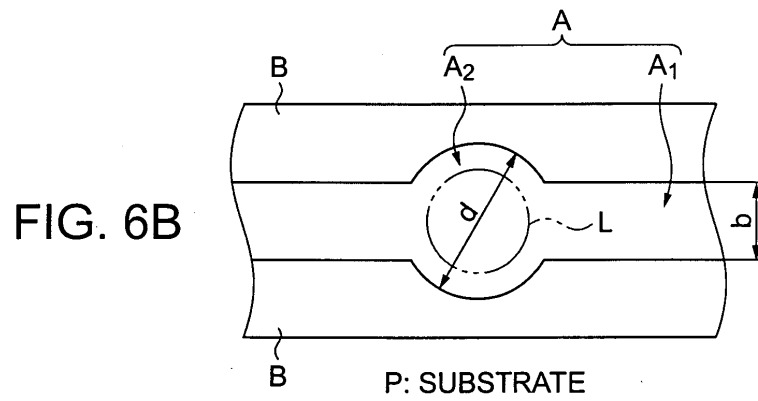
(54) **Substrate provided with a thin film pattern for an electro-optic device**

(57) A thin film pattern substrate, including an area provided to the substrate to form a recess and including a wider section and a linear section connected to the wider section, wherein the wider section having a width

greater than the width of the linear section, and a thin film pattern provided on the area, wherein a mean diameter of the wider section is set to be no greater than double the width of the linear section.

FIG. 6A







EUROPEAN SEARCH REPORT

Application Number
EP 05 02 3648

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			H01L H05K
The present search report has been drawn up for all claims			
Place of search The Hague		Date of completion of the search 3 March 2011	Examiner Fratiloiu, Silvia
CATEGORY OF CITED DOCUMENTS X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document		T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document	

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**ANNEX TO THE EUROPEAN SEARCH REPORT
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EP 05 02 3648

This annex lists the patent family members relating to the patent documents cited in the above-mentioned European search report.
The members are as contained in the European Patent Office EDP file on
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